

# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

## Title of Invention

MULTI-LAYER INTEGRATED SEMICONDUCTOR  
STRUCTURE HAVING AN ELECTRICAL SHIELDING PORTION

Application Number : 10/749096  
Confirmation Number: 3177  
First Named Applicant: Rafael Reif  
Attorney Docket Number: MIT-136DUS  
Art Unit: 3745  
Examiner:  
Search string: ( 5523628 or 6717244 ).pn



## US Patent Documents

**Note: Applicant is not required to submit a paper copy of cited US Patent Documents**

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5523628	1996-06-04	Williams et al.			
	2	6717244	2004-04-06	Hikita et al.			

## Signature

Examiner Name	Date